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**Complete if Known**

Application Number	10/628,174
Filing Date	07/28/2003
First Named Inventor	KOOPS
Art Unit	1763
Examiner Name	OLSEN
Attorney Docket Number	8183

## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	Footnote
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	MM-DD-YYYY			
AWO		WO 02 19375 A	03-07-2002	REINHARDT	ENTIRE DOCUMENT	
AWO		DE 100 42 098A	03-14-2002	REINHARDT	ENTIRE DOCUMENT	
AWO		ISR/EP 02023217	04-29-2003	NaWoTec GmbH	ENTIRE DOCUMENT	

Examiner Signature	/Allan Olsen/ (07/06/2006)	Date Considered	
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>			
		Application Number	10/628,174		
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		Examiner Name	OLSEN		
Sheet	2	of	2	Attorney Docket Number	8183

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
AWO		KOOPS, HIGH-RESOLUTION ELECTRON-BEAM INDUCED DEPOSITION, JOURNAL OF VACUUM SCIENCE: PART B, 1988, PAGES 477-481, V 6, NO. 1, AMERICAN INSTITUTE OF PHYSICS, NEW YORK, US	
AWO		HAIGHT et al., MARS: Femtosecond laser mask advanced repair system in manufacturing, J. Vac. Sci. Technol. B17(6), Nov/Dec 1999, 3137-3143, 17(6), American Vacuum Society,	
AWO		EHRlich et al., A REVIEW OF LASER-MICROCHEMICAL PROCESSING, J. Vac. Sci. Technol. B, Oct.Dec. 1983, 969-984, Vol. 1, No. 4, American Vacuum Society.	

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